

## Raina, et al.

Atty Docket: MICRON.111CI



(PRIOR ART)

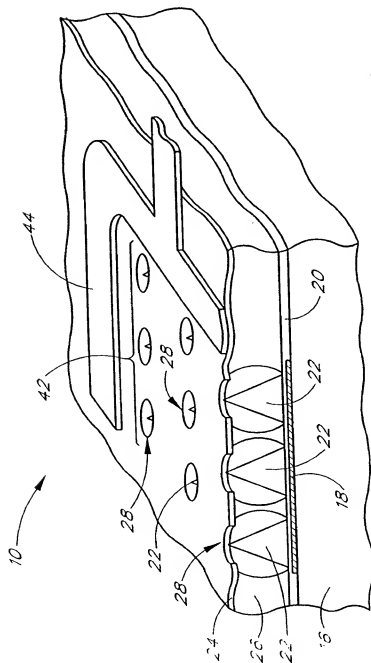


FIG. 2

(PRIOR ART)

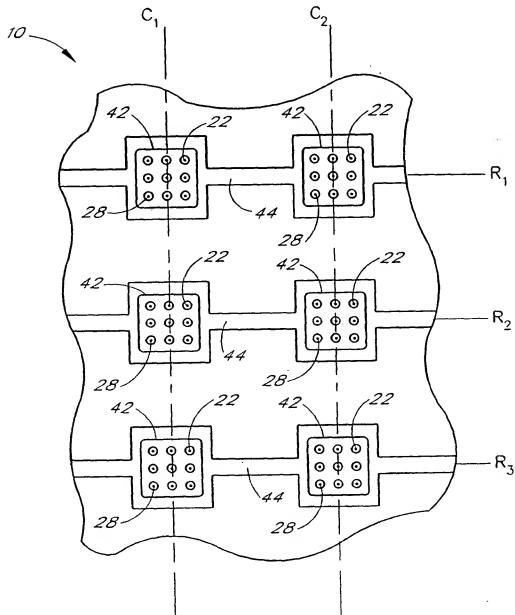


FIG. 3

(PRIOR ART)

NITROGEN AND PHOSPHORUS DOPED AMORPHOUS SILICON AS  
RESISTOR FOR FIELD EMISSION DISPLAY DEVICE BASEPLATE

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Appl. No.: Unknown

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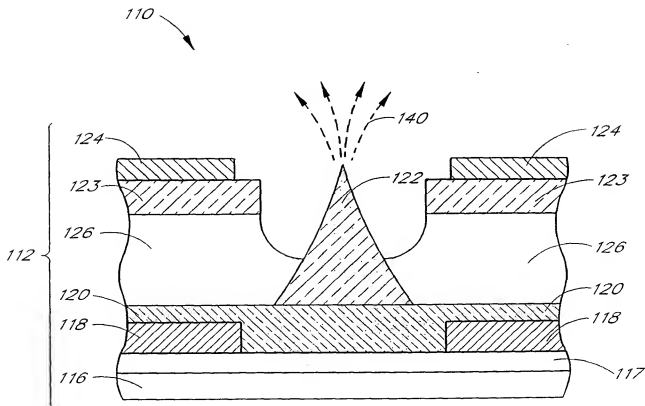


FIG. 4

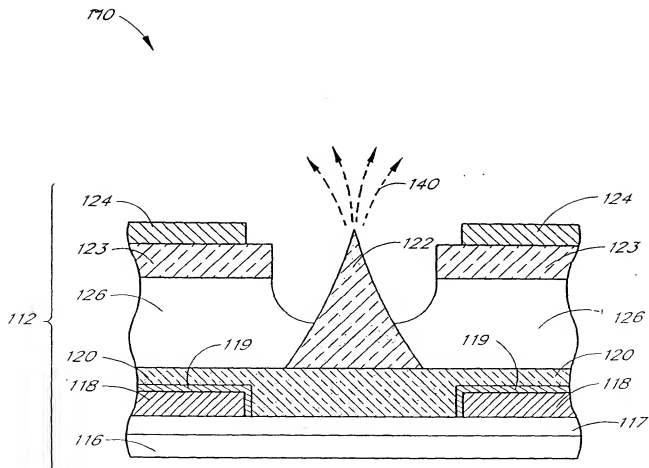


FIG. 5